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ARTICLE

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Analysis of a Casimir-driven parametric amplifier with resilience to Casimir pull-in for MEMS single-point magnetic gradiometry

Josh Javor¹✉, Zhancheng Yao², Matthias Imboden³, David K. Campbell^{2,4,5} and David J. Bishop^{1,2,4,5,6}

Abstract

The Casimir force, a quantum mechanical effect, has been observed in several microelectromechanical system (MEMS) platforms. Due to its extreme sensitivity to the separation of two objects, the Casimir force has been proposed as an excellent avenue for quantum metrology. Practical application, however, is challenging due to attractive forces leading to stiction and device failure, called Casimir pull-in. In this work, we design and simulate a Casimir-driven metrology platform, where a time-delay-based parametric amplification technique is developed to achieve a steady-state and avoid pull-in. We apply the design to the detection of weak, low-frequency, gradient magnetic fields similar to those emanating from ionic currents in the heart and brain. Simulation parameters are selected from recent experimental platforms developed for Casimir metrology and magnetic gradiometry, both on MEMS platforms. While a MEMS offers many advantages to such an application, the detected signal must typically be at the resonant frequency of the device, with diminished sensitivity in the low frequency regime of biomagnetic fields. Using a Casimir-driven parametric amplifier, we report a 10,000-fold improvement in the best-case resolution of MEMS single-point gradiometers, with a maximum sensitivity of 6 Hz/(pT/cm) at 1 Hz. Further development of the proposed design has the potential to revolutionize metrology and may specifically enable the unshielded monitoring of biomagnetic fields in ambient conditions.

Introduction

Quantum fluctuations in an electromagnetic field give rise to forces between conductors at the same potential when their separation is near 100 nm. Known as the Casimir force, this phenomenon was first predicted by H. B. G. Casimir¹ and was later expanded to arbitrary materials^{2,3}. Since then, the Casimir force has been measured experimentally many times^{4–11} and has been proposed as a practical metrology platform using micro- and nanoelectromechanical systems (MEMS/NEMS)^{4–6,12}. The Casimir force is attractive for metrology

applications due to its extreme sensitivity to the separation between two objects and the ability to be measured in ambient conditions⁵. One of the most critical challenges in the development of practical platforms is resilience to Casimir pull-in, which results in stiction in MEMS/NEMS devices and typically irreversible damage^{13,14}. Notably, Casimir pull-in is only an obstacle in devices that employ an attractive force^{4–6,8–11,13}, but a specific combination of materials can generate a repulsive force as well^{7,15}. The repulsive force configuration, however, has only been observed in liquid, which is not ideal for many common MEMS/NEMS applications such as resonant sensing. As such, many have proposed avoiding pull-in in attractive force platforms by optimizing the material dielectric properties¹⁶, the radius of curvature in a sphere-plate configuration¹⁷, and the roughness of interacting surfaces^{18,19}. A device capable of leveraging the attractive

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Casimir force while resilient to pull-in would realize great utility for quantum metrology.

Quantum metrology has longstanding application in the measurement of very weak magnetic fields. A superconducting quantum interference device (SQUID) measures changes in the magnetic field associated with a flux quantum²⁰. An atomic magnetometer (AM) measures a quantum effect involving the magnetic spin states of atoms in a vapor cell²¹. The list of applications for such high-resolution magnetic sensors is vast, spanning the biomagnetic detection of cardiac contractions^{22,23}, electromagnetic brainwaves²⁴, and solid cancerous tumors²⁵ to astronomical observations such as Jupiter's magnetosphere²⁶. Sensitive magnetometry is often challenged by interference from ambient geomagnetic fields and nearby electromagnetic sources. For real-time measurements, the most common methods to reduce the effects of interference are magnetic shielding and gradiometry. Shielding is both expensive and cumbersome, so there is a great effort to conduct unshielded measurements^{23,24}. Today, gradiometry is only applied via differential measurement, measuring the subtraction from two closely spaced sensors. Such a technique increases immunity to interference by reducing sensitivity to temporal fluctuations in magnetic intensity. This is especially effective for measurement near a magnetic source (such as the heart^{23,24}), where magnetic gradients are high, and for use with magnetic sensors which are robust and reliable. In our recent work, we demonstrate magnetic gradiometry without subtraction at single point²⁷, and at a resolution in the range of magnetocardiography (MCG).

Existing gradiometer technology is reviewed in Fig. 1, which is repurposed from ref. ²⁷ for this work. The fields are illustrated in gradients, assuming the sensors of each technology can be separated by 1 cm. All technologies involve subtraction between two sensors to calculate the gradient, except the MEMS single-point gradiometer²⁷. The first-order gradients of the geomagnetic field (E , 500 pT/cm) and geomagnetic noise (GMN, 500 fT/cm) are illustrated by dash-dotted lines. SQUID and AM technology clearly lead the group in resolution. Myriad other techniques are used to sense magnetic fields, where the bottom band (in purple) represents MEMS designs. MEMS magnetic sensors are typically resonant sensors with high-quality factors (Q greater than 1000), where impressive sensitivity has been achieved at higher frequencies in the kHz range^{27–29}. To detect low-frequency biomagnetic fields, nontrivial techniques are necessary to employ resonant sensors.

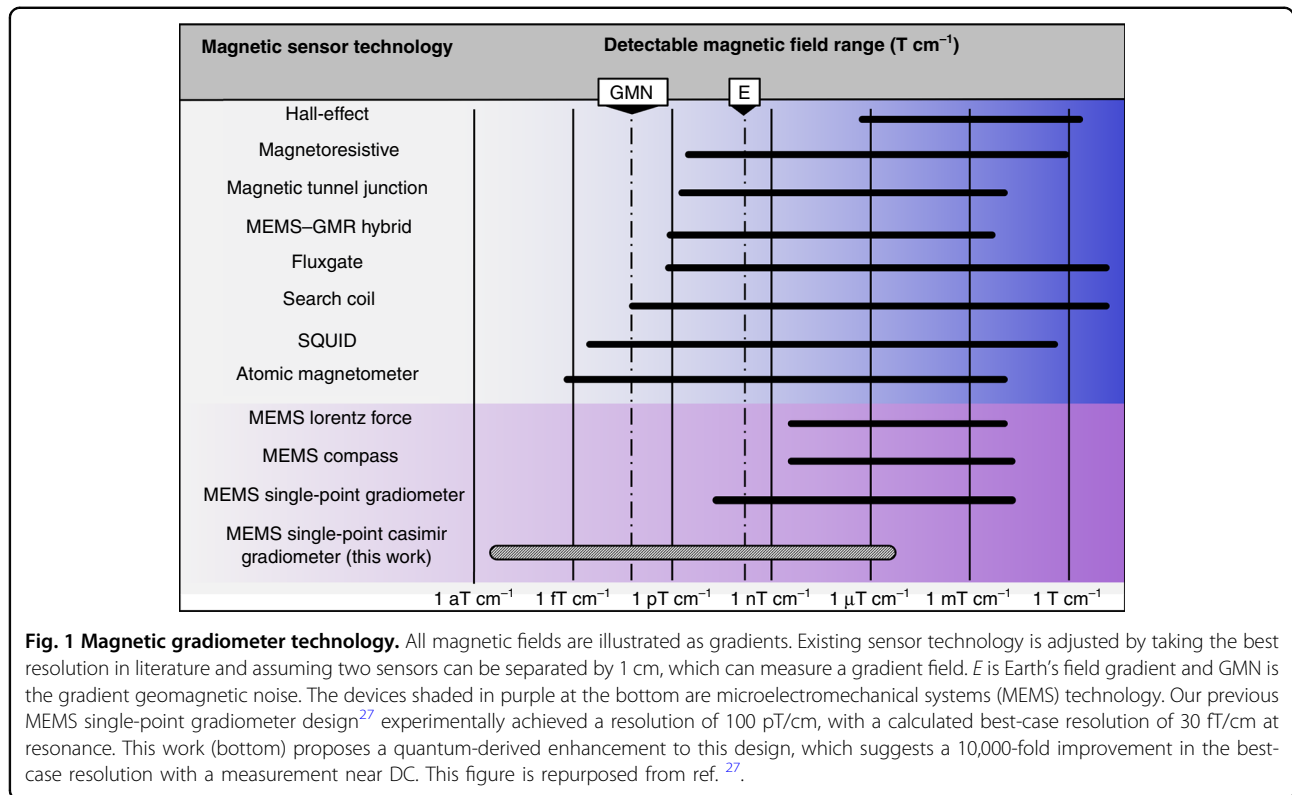
The sensitivity of resonant MEMS devices can be tuned by many techniques such as parametric amplification^{12,30,31} and modal coupling^{32,33}. Conceptually, parametric amplification is typically achieved by modulating a parameter of the equation of motion at two times the

frequency of resonance and controlling the phase relation between the driven mode and the modulated parameter. When applied to the drive system of a MEMS cantilever³⁰, thermomechanical noise was reduced in one phase by 4.9 dB. A Lorentz force MEMS magnetometer was parametrically driven to enhance sensitivity at resonance by over 80-fold³¹. The gain in such electrostatic systems is typically 10–1000. Parametric modulation can also be applied to coupled resonators, where one object, or mode, oscillates at twice the frequency of another. Parametric pumping was shown to dynamically tune the coupling of two modes in a gyroscopic ring resonator, with application in inertial sensing³². In the design of a Casimir-coupled resonator¹², a gold sphere was used to parametrically pump the oscillation of a torsional oscillator, proposed to amplify a DC voltage measurement up to ten orders of magnitude. Using an attractive Casimir force design, the challenge of avoiding Casimir pull-in was also discussed in depth. The tunability of such systems is often critical for experimental utility and to account for small fabrication asymmetries, which have a significant impact on the coupling^{12,32}.

In this work, we propose a coupling between two resonators by a quantum-derived Casimir force. Fundamentally, we combine two metrology platforms: a MEMS Casimir platform and a MEMS single-point gradiometer platform. The Casimir platform⁵ comprises a MEMS accelerometer functionalized by a gold sphere, where the voltage potential can be controlled. A Casimir force measurement is achieved when a gold plate is brought within 100 nm of the sphere. The MEMS gradiometer platform²⁷ comprises a MEMS accelerometer functionalized by a cube micromagnet. Measurement is achieved by detecting an oscillating force on the permanent magnet at resonance, where the force is proportional to a gradient magnetic field. Both resonators can also be electrostatically driven in an analog environment^{5,27,34}. In essence, these two systems, on the same central axis and within 100 nm of separation, form a Casimir-coupled resonator. Similar to a Casimir oscillator using a torsional plate¹², this design is highly sensitive to small changes in DC separation due to Casimir coupling. Therefore, DC forces from gradient magnetic fields are intensely amplified by the coupling. Then, instead of using parametric amplification to further amplify the sensitivity, we design a technique to achieve a steady-state Casimir oscillator resilient to pull-in. In this work, we propose and simulate a highly tunable Casimir-driven gradiometer that is sensitive to slowly varying magnetic fields and resilient to pull-in.

MEMS Casimir gradiometer design

The design in this work is a nontrivial combination of an experimental MEMS gradiometer platform²⁷, an



experimental MEMS Casimir force metrology platform⁵, and a coupling method¹² that parametrically modulates the interaction between the two platforms. To approach the divergent gain of this physical design, we anticipate that a tunable experimental platform with precise positional control of the two microobjects (magnet and sphere) is required. When the separation is reduced to near 100 nm, the Casimir force contribution becomes significant, as has been shown previously^{4,5}. If the separation decreases much past this point, the system is predicted to experience Casimir pull-in, an event that is caused by the attractive Casimir force overcoming the restoring force of the spring and causing the device to malfunction.

The proposed sensing platform is illustrated in Fig. 2a. Each device is fabricated individually as described previously^{5,27} using commercially available MEMS accelerometers. This is accomplished using precise control of a vacuum pick-and-place system and feedback from a live sensor (postrelease MEMS). The micromagnet used in the gradiometer design is functionalized with a gold plate on its side that faces the microsphere. The sensor with the microsphere is inverted such that the sphere has a clear pathway to come into close proximity to the plate. Both platforms enable control of static position, oscillation amplitude, frequency, phase, and detection. The drive parameters are controlled via a built-in electrostatic self-test feature on the ADXL 203 platform, which can be used for

analog control of the microobjects via pulsed width modulation³⁴. This feature is also used to calibrate and negate the effect of an anticipated electrostatic coupling between the plate and sphere, as has been shown previously⁵.

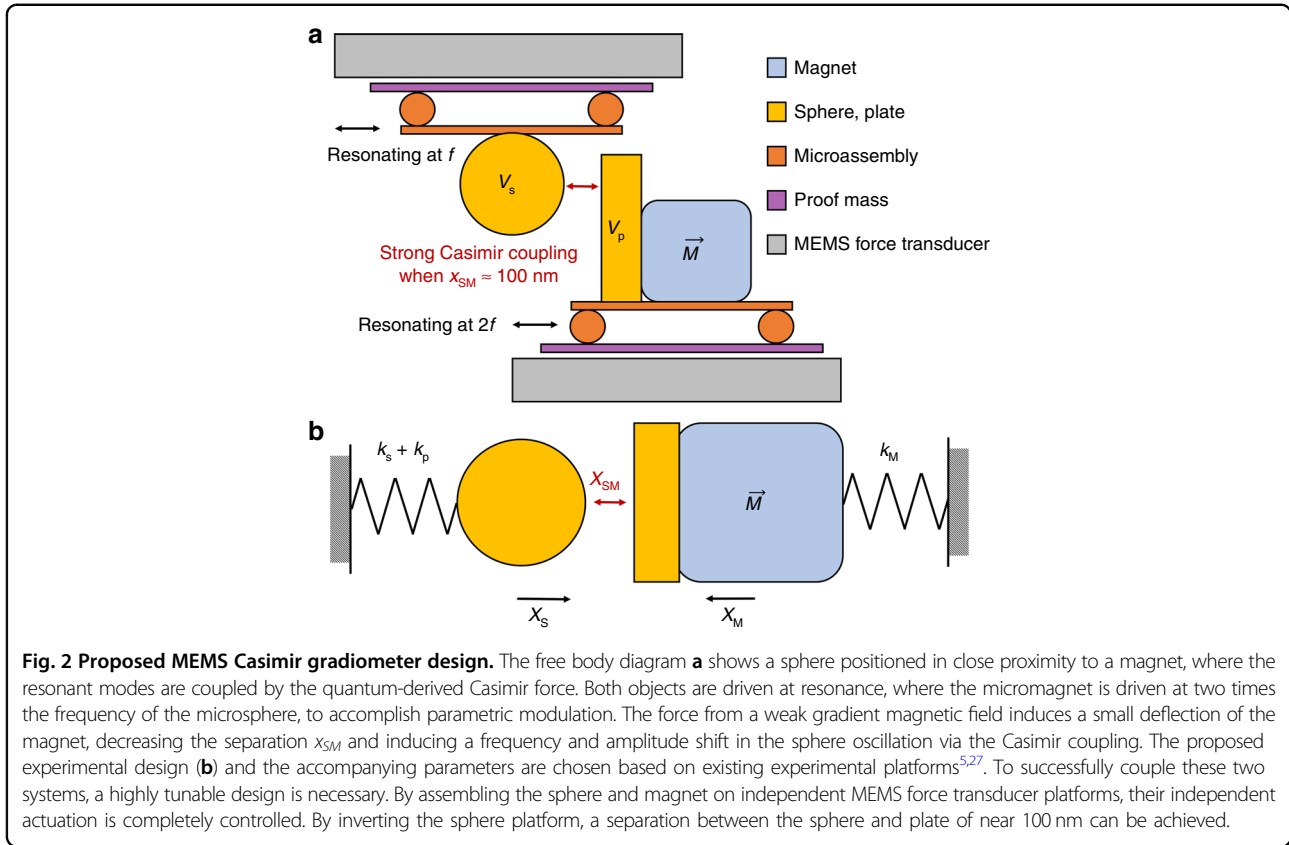
The functional diagram of this design, shown in Fig. 2b, is based on the interaction of two resonators. The first resonator includes an attached gold microsphere, and the second includes the micromagnet/gold mirror assembly. Independently, both resonators act as damped, driven harmonic oscillators. The coupling of the two resonators is based on the Casimir force, which is dependent on their separation. Assuming that out-of-plane forces are minimal, we analyze a uniaxial system of equations (Eqs. 1–3) along the central axis of the magnet.

$$m_S \ddot{x}_S + \frac{m_S \omega_{OS}}{Q_S} \dot{x}_S + k_{OS} x_S = F_{Dr-S}(t) + F_{Cas}(x_{SM}, t) \quad (1)$$

$$m_M \ddot{x}_M + \frac{m_M \omega_{OM}}{Q_M} \dot{x}_M + k_{OM} x_M = F_{Dr-M}(t) + F_{Cas}(x_{SM}, t) + F_M(t) \quad (2)$$

$$x_{SM}(t) = s_0 + x_S(t) - x_M(t) \quad (3)$$

Here, Eq. 1 relates to the sphere, Eq. 2 to the magnet, and Eq. 3 to their separation. In Eq. 1, x_S is the displacement of the sphere, m_S is the mass, ω_{OS} is the natural frequency, Q_S is the quality factor, and k_{OS} is the unperturbed spring constant. The sphere is driven electrostatically by F_{Dr-S} and



experiences an attractive coupling force F_{Cas} when the separation is small (on the order of 100 nm). Similarly, in Eq. 2, x_M is the displacement of the magnet, m_M is the mass, ω_{0M} is the natural frequency, Q_M is the quality factor, and k_{0M} is the spring constant. The magnet is also driven electrostatically by a force F_{Dr-M} and experiences an equal and opposite coupling force to the sphere F_{Cas} at small separations. In addition, a slow, time-varying gradient magnetic field imposes a force F_M . In Eq. 3, x_{SM} is the real-time separation distance between the sphere and magnet, and s_0 is the separation in the absence of the Casimir coupling force. The forcing terms are expanded in Eqs. 4–7 below.

$$F_{Dr-S}(t) = k_0 S A_S \sin(\omega_{0C}(t + \tau_{1f})) \tag{4}$$

$$F_{Dr-M}(t) = k_0 S A_M \sin(2\omega_{0C}(t + \tau_{2f})) \tag{5}$$

$$F_M = M \left(\frac{dB}{dx} \right) \cos(\theta) \tag{6}$$

$$F_{Cas} = - \frac{\pi^3 \hbar c}{360} \frac{R}{x_{SM}^3} \tag{7}$$

In Eq. 4, A_S is the forcing amplitude of the sphere, ω_{0C} is the natural frequency of the coupled system, and τ_{1f} defines the fixed starting time. Similarly, in Eq. 5, A_M is

the forcing amplitude of the magnet, and τ_{2f} is the time delay of magnet actuation. Most works^{12,30,31} involving parametric pumping use a phase delay, and we describe our rationale for a time delay system later, in conjunction with Fig. 3. The magnet is forced at $2\omega_{0C}$ for parametric amplification. Equation 6 describes the force on the magnet from a gradient magnetic field predominantly along its polarized axis, where M is the moment, B is the magnetic field intensity, and θ is the angle between them²⁷. The Casimir force for a sphere-plate geometry is displayed in Eq. 7, where \hbar is Planck's constant, c is the speed of light, R is the radius of the sphere, and x_{SM} is the separation between the sphere and plate as defined above. It should be noted that Eq. 7 is ideal (assuming absolute zero temperature and perfectly smooth infinitely conducting surfaces) and should be modified to reflect real experimental conditions^{4–11} such as temperature, roughness, and dielectric properties. The nominal values for simulation inputs are shown in Table 1, where the primary tuning parameters are indicated. The magnet's mass (typically 150 μg ; see ref. 27) is not a direct input to the simulation, as the magnet's dynamics are controlled by feedback (discussed later in Fig. 3).

When the two resonators are coupled as described in Eqs. 1–3, there is a spring softening effect analogous to

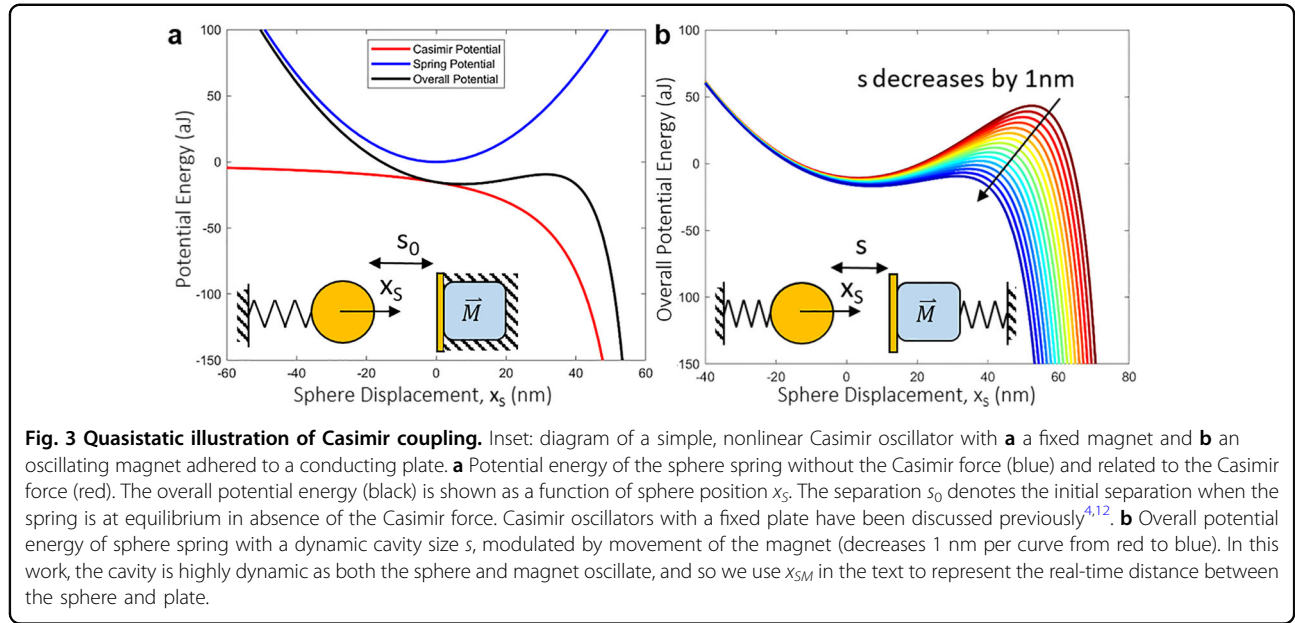


Table 1 Parameter Inputs for Simulation of Casimir Gradiometer Design.

Parameter	Symbol	Nominal value
Uncoupled resonant frequency	$\omega_{0s}/(2\pi)$	1 kHz
Quality factors (both resonants)	Q	1000
Sphere spring constant	k_{0s}	25 mN/m
Magnet spring constant	k_{0M}	25 mN/m
Sphere mass	m_s	1 μ g
Sphere radius	R	60 μ m
Sphere AC amplitude	A_s	20 nm
Sphere time delay	τ_{1f}	1.02 ms
Magnet AC amplitude	A_M	10 nm
Magnet time delay	τ_{2f}	750 μ s
Separation	s_0	~100 nm

The values are largely chosen based on reasonable implementation to existing experimental platforms^{5,27}. Although not directly an input to the simulation, the typical mass m_M of the cube micromagnet in this design (with 250 μ m side length) is 150 μ g (ref. ²⁷).

the electrostatic spring softening observed in capacitive systems³⁰. The coupling may then be modulated by tuning the parameters of the magnet resonator. This is necessary to access the most sensitive region of parameter space while preventing Casimir pull-in. Following the analytical model outlined earlier¹², the equation of motion for the sphere (Eq. 1) in a Casimir coupled system then becomes Eq. 8 below, where the parametric spring constant k_p is defined in Eqs. 9 and 10. For simplicity, we maintain the assumption of a linear spring model because

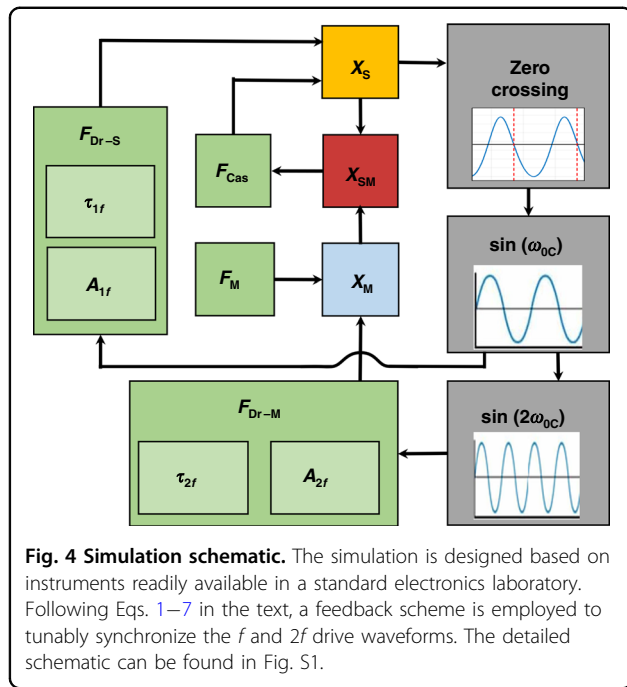
the amplitudes of oscillation are small (<100 nm).

$$m_s \ddot{x}_s + \frac{m_s \omega_{0C}}{Q_C} \dot{x}_s + [k_{0s} + k_p(x_{SM}, t)] x_s = F_{Dr-s}(t) + F_{Cas}(x_{SM}, t) \tag{8}$$

$$k_p(s_0, t) = \frac{dF_{Cas}(x_{SM}, t)}{dx_{SM}} \tag{9}$$

$$k_p(s_0) = \frac{\pi^3 \hbar c}{120} \frac{R}{x_{SM}^4} \tag{10}$$

The effect of the modulated spring constant may be best illustrated by the potential energies of a quasi-static system (Fig. 4). The magnet is fixed (Fig. 4a), and the sphere, connected to a spring, is moved to set the gap between it and the conducting plate. The gap is the Casimir cavity size s_0 , which is defined by the equilibrium position of the spring in the absence of the Casimir force. This has been described earlier⁴ for a Casimir oscillator where s_0 is constant. In this work, the cavity s is influenced by the movement of both the magnet and spring. The overall potential energy curve is a summation of the elastic potential energy of the spring and the potential energy of the Casimir force as a function of the sphere displacement x_s from the equilibrium position. At greater displacements, the Casimir attraction overcomes the restoring force, and pull-in occurs as the overall potential decreases rapidly. The overall potential energy curve is shown for varying Casimir cavity sizes (Fig. 4b), where each curve (from red to blue) represents the cavity decreasing by 1 nm (this is quasistatic, so the cavity size is represented by s). Now that the quasistatic system is understood, it is



straightforward that the potential energy curve changes dynamically as the sphere and magnet both move in real-time (a dynamic cavity is represented by x_{SM}). Thus, with the appropriate tuning of the magnet oscillation, one can modulate the sphere oscillation via Casimir coupling. Furthermore, one can make a trade-off to tune the stability and sensitivity of the system as a larger amplitude pushes the sphere close to pull-in, which makes the system more unstable but more sensitive to small perturbations on the magnet.

The system described is a complex combination of several physical phenomena, leading to a highly nonlinear system and a large parameter space. Therefore, simulations using MATLAB’s Simulink and Simscape are chosen to characterize the system. A simplified block diagram is illustrated (Fig. 3), and a detailed block diagram is provided in the Supplementary Material (Fig. S1). In essence, the nominal parameters in Table 1 are input to the system, and the outputs are tracked in real-time. The sphere amplitude x_S is reported to gather a clear sense of the operation of the device, and the change in the coupled system resonant frequency ω_{0C} is the ultimately proposed detection method. These values are gathered at some point in the time response after the initial transients have settled (typically 0.35 s). We designed the simulation only with tools we typically use in the laboratory to facilitate the translation to experimental measurement. A feedback approach is employed, where the sphere’s frequency is detected by a zero-crossing (negative slope). A waveform at double the frequency involving the Casimir coupling

and a gradient magnetic field is fed back into the actuation of the sphere.

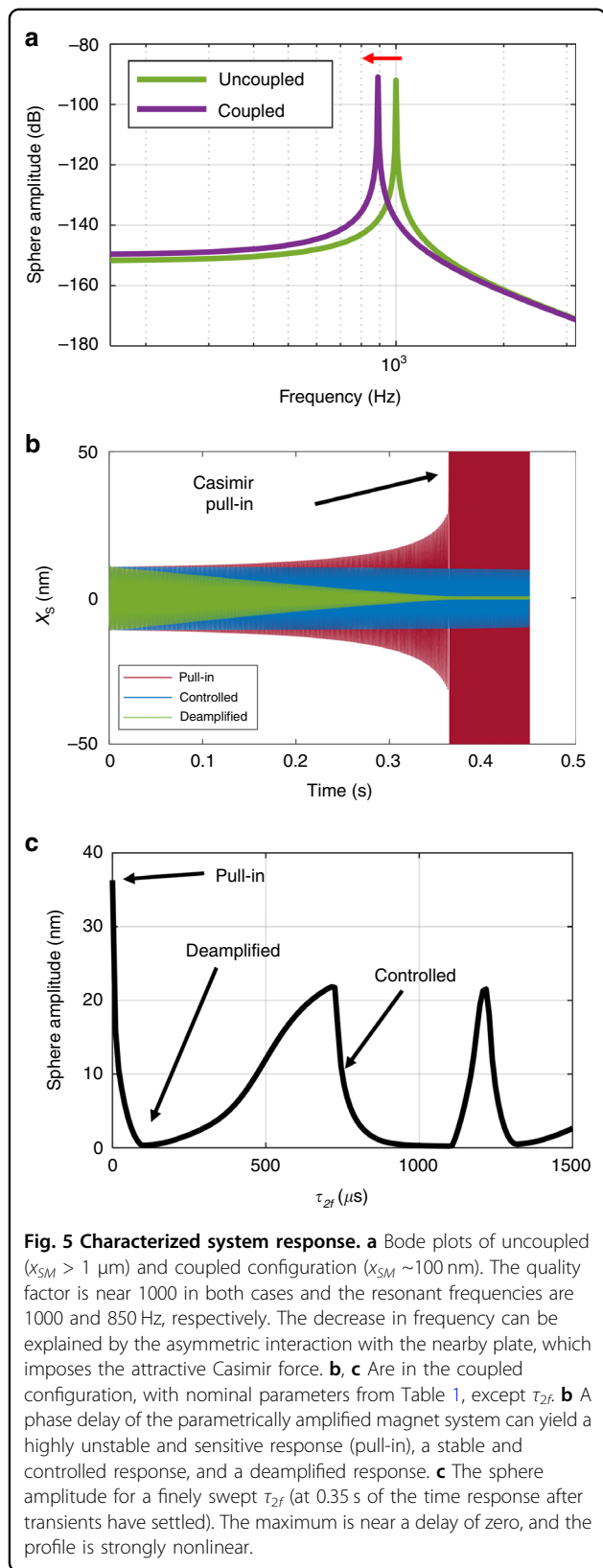
At the start of the simulation ($t = 0$), we assume that the sphere is resonating at the unloaded resonance frequency ω_{0S} , and the magnet is resonating at $2\omega_{0S}$. The objects are proposed to incrementally approach each other from a large separation distance ($>1 \mu\text{m}$, where the Casimir force is minimal) to reach the prescribed separation. This approach is based on the experimental observation⁵ of the Casimir force using a similar platform. As Casimir coupling begins to interact, our feedback system adjusts the actuation of the sphere (Fig. 3). The resonant mode of the system is pumped such that there is little amplitude decay due to damping, a technique³⁵ that is well characterized in both simulations and experiments. Previous analytical¹² and experimental^{30,31} works have controlled the phase of objects in a parametrically amplified system, but this is challenging to do in dynamic simulation experiments, such as with Simulink.

This is ultimately why we choose a time delay approach, where the translation to experiment is straightforward with a precision digital delay generator (such as the DG645, SRS). It is worth noting, however, that a constant time delay will result in a changing phase delay for a system with changing oscillation frequency (as is our case). Therefore, this design is notably different from a phase delay parametric pumping system.

A gradient magnetic field is introduced to the system in Fig. 3 by a force F_M on the magnet. This results in a linear deflection of the magnet by Eq. 6, changing x_M , and dynamically altering the separation x_{SM} . This force is imposed statically in Figs. 5 and 7 and is imposed dynamically in Fig. 6. The sphere amplitude is reported to intuitively convey the behavior of the device, but the resonant frequency of the coupled system is measured to infer the measurand, a gradient magnetic field. As such, we define a sensitivity S_{freq} (Hz/pT/cm), shown in Eq. 11, as the ratio between the natural frequency of the coupled system f_{0C} and the change in gradient magnetic field ∇B_x . In Fig. 7, this is computed by taking the slope between two consecutive data points.

$$S_{\text{freq}} = \frac{\Delta f_{0C}}{\Delta(\nabla B_x)} \tag{11}$$

Parametric pumping is expected to enhance the coupling of the Casimir force. Analytically, sphere-plate Casimir coupling showed a maximum gain proportional to the inverse of the 5th power of the separation when a phase delay of 0° (or time delay of 0 s) was used and the sphere amplitude was detected¹². To our knowledge, there is no experimental observation of parametrically amplified Casimir coupling. Due to the anticipated danger of pull-in at maximum amplification, we identify a region



of design space resilient to pull-in and with parametrically amplified Casimir coupling. We leverage a shift in the coupled resonant frequency to propose a frequency detection scheme.

Results: Magnetic sensing with the MEMS Casimir gradiometer

The system is characterized by simulation (Fig. 5), where the results from the dynamics of the sphere are analyzed. The uncoupled and Casimir coupled systems are illustrated using Bode plots (Fig. 5a). As shown in Table 1, the resonant frequency of the unloaded system is designed to be 1 kHz with a quality factor of 1000. Casimir coupling causes a pronounced decrease in the resonant frequency (tens to hundreds of Hz). The high-quality factor of the system facilitates frequency shift detection. Recall that the uncoupled case occurs when the separation between the sphere and magnet is larger than $1 \mu\text{m}$. At such separations, the sphere responds to a harmonic drive with symmetric oscillations shepherded by the spring's linear restoring force. The coupled case occurs when the separation between the magnet and sphere is in the range of 100 nm. In this regime, the spring's restoring force deviates from parabolic, becoming asymmetric (Fig. 4) and leading to nonlinear dynamics.

In the coupled configuration, the parameters are tuned to characterize the system and investigate useful areas of design space. The first parameter of interest is the time delay of the magnet's oscillation τ_{2f} . In Fig. 5b, we show the temporal response to various time delays, labeled pull-in ($\tau_{2f} = 0 \mu\text{s}$), Controlled ($\tau_{2f} = 750 \mu\text{s}$), and Deamplified ($\tau_{2f} = 150 \mu\text{s}$). This characterizes three responses for different values of τ_{2f} , and the responses to finely swept values are characterized (Fig. 5c) by the AC amplitude of the sphere after transients have settled ($t = 0.35 \text{ s}$). We find a maximum amplification at $\tau_{2f} = 0 \mu\text{s}$ (corresponding to a phase delay of 0°), which is consistent with the previous analytical analysis¹² of a phase delay system. While the $\tau_{2f} = 0 \mu\text{s}$ delay is the most sensitive region of the design space, we find that the two resonators in the Casimir coupled system always result in pull-in if left to interact for an arbitrarily long time. This indicates malfunction and destruction of the sensor. Consequently, we avoid this region of design space and investigate nonzero time delays for a sensitive controlled condition. For nonzero time delays, however, this system is different than a phase delay system and may not be directly compared. We find a maximum deamplification at $\tau_{2f} = 150 \mu\text{s}$ followed by two other maxima (Fig. 5c). After the peak at $\tau_{2f} = 1200 \mu\text{s}$, the pattern repeats with slightly decreased amplitudes due to energy lost per cycle (not shown). At $\tau_{2f} = 750 \mu\text{s}$, we report a stable, controlled oscillation of the sphere (Fig. 5b), which is expanded in Figs. 6 and 7.

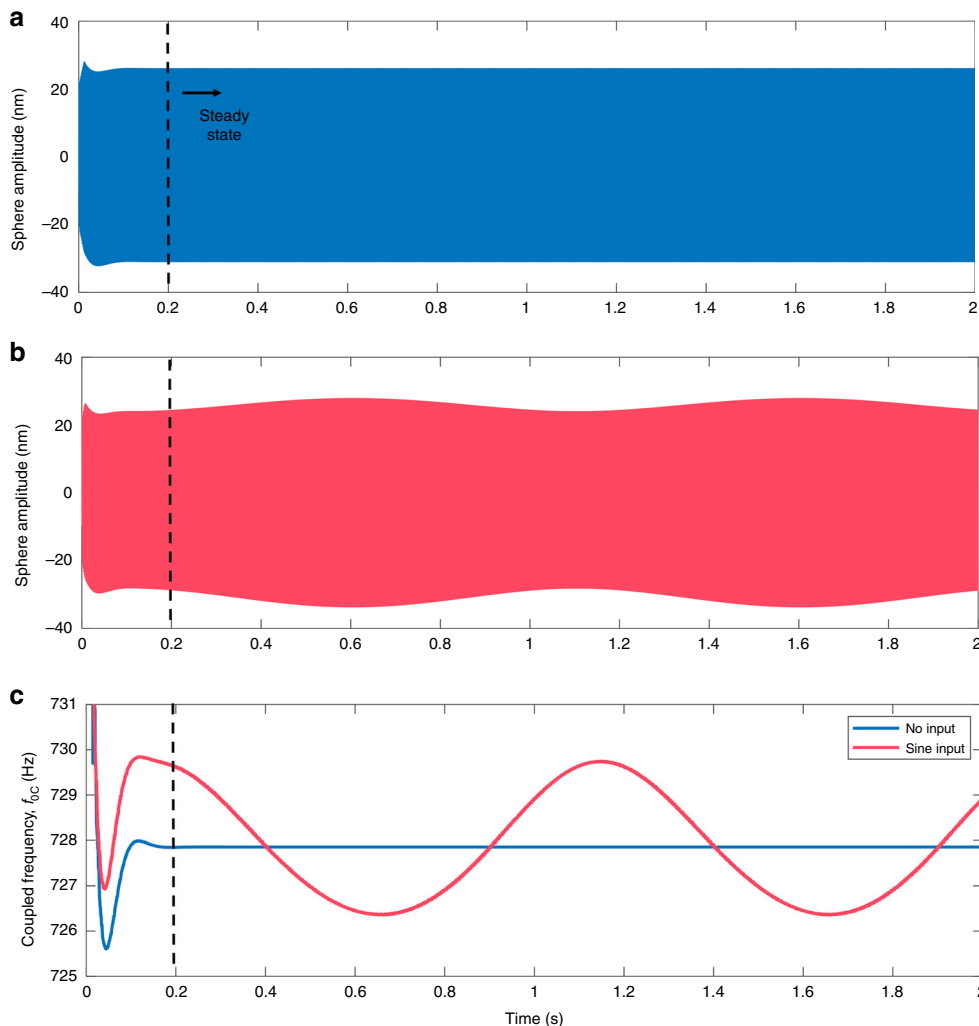


Fig. 6 Response to slowly varying gradient magnetic field. The controlled configuration at $\tau_{2f} = 750 \mu\text{s}$ is tracked for 2 s following an imposed initial condition. **a** Shows the sphere amplitude response to no magnetic field input, where the two resonators are set to interact and reach a steady-state after approximately 200 ms. **b** Shows the sphere amplitude response when the magnet is modulated by a 1 Hz, 4 pT/cm peak-to-peak gradient magnetic field. **c** Tracks the shift in the coupled resonance frequency f_{0C} in both conditions **(a)** and **(b)**. A 1 Hz oscillation is observed in both **(b)** and **(c)**, where tracking the frequency shift of the high-quality peak reports a clean signal. For small deflections of the magnet (1 nm peak-to-peak here), the response is nearly linear, but larger deflections will result in an asymmetric sine wave.

The time response of the controlled system ($\tau_{2f} = 750 \mu\text{s}$) is dynamically characterized over an elapsed time of 2 s for zero gradient magnetic field input (Fig. 6a) and for a slowly varying sine wave oscillation of a gradient magnetic field (Fig. 6b). The resonant frequency of the coupled system in these two conditions, f_{0C} , is tracked in both configurations (Fig. 6c). The coupled system with no input field reaches a steady state after approximately 200 ms, after which point the signal is stable. A dynamic gradient field input of a 1 Hz sine wave, 4 pT/cm peak-to-peak, is chosen to demonstrate the response of the system to a slowly varying magnetic field. For a gradiometer²⁷ sensitivity of $1 \mu\text{V}/(\text{fT}/\text{cm})$ and a magnet spring constant of 25 mN/m (40 times softer than the experimental

platform in ref. ²⁷), this gradient field yields a 1 nm peak-to-peak oscillation of the magnet. The system responds with a 1 Hz oscillation of an approximately 4 Hz peak-to-peak shift in f_{0C} . For very small gradients, the response is nearly linear, and for larger gradient fields, the response is a nonlinear, asymmetric sine wave. However, the change in the coupled resonant frequency directly maps to a change in the gradient, so the true gradient signal can be easily calculated by ratiometric conversion.

The sensitivity S_{freq} is tunable with respect to separation (Fig. 7). System parameters of $\tau_{2f} = 750 \mu\text{s}$ and $A_{2f} = 1 \text{ nm}$ are selected. For changing separation x_{SM} , the change in f_{0C} is recorded on the first y-axis (right). Sensitivity, on the second y-axis (left), is calculated using Eq. 11. The

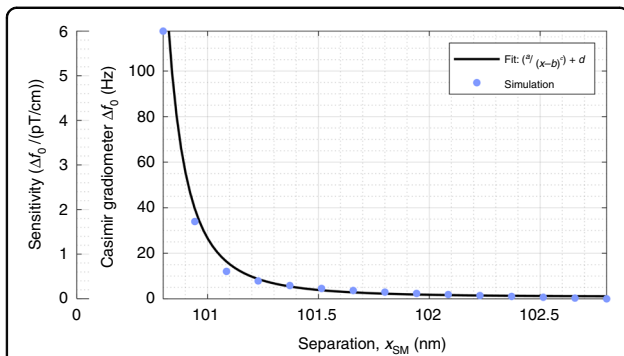


Fig. 7 Tunable sensitivity to separation. The separation x_{SM} is varied in a 3 nm range, resulting in an inverse exponential profile in a frequency shift of the coupled resonance f_{0C} . The sensitivity S_{freq} is calculated using a gradient magnetic field that would cause an equivalent deflection in x_{SM} . The maximum sensitivity reported is 6 Hz/(pT/cm). Standard frequency detection with 10 ppm and a 1 s gate time yields a best-case resolution of 1.6 aT/cm. While we anticipate limitations due to thermomechanical noise, this exceeds a 10,000-fold improvement on the previous design²⁷ of the MEMS single-point gradiometer. While a zero delay configuration may provide maximum amplification, we report a highly sensitive design using a $\tau_{2f} = 750 \mu s$ delay, which is resilient to Casimir pull-in.

gradient field used to calculate sensitivity is the equivalent field that deflects the magnet, altering x_{SM} . An inverse power function profile is observed as a result. Such a profile is expected, as the Casimir force follows an inverse cubic function with respect to separation (Eq. 7). This design is not static, however, and the parametric pumping (Eq. 8) modifies the dynamics. As introduced earlier, an analytical work¹² with an equivalent time delay of 0 s proposed detection proportional to the 5th power of the separation. We find the region with zero delays to lead to pull-in (Fig. 5b) and utilize the controlled response found at $\tau_{2f} = 750 \mu s$. To compare to the previously proposed detection scheme at maximum amplification, we use an inverse exponential fit $y = a/(x - b)^c + d$, where a , b , c , and d are constants and c describes the power relationship. Fitting the data in Fig. 7 yields $c = 2.6$ for our proposed frequency detection scheme. While this is significantly less sensitive than the 5th power relationship ($c = 5$), the Casimir coupling is amplified and resilient to pull-in.

The best-case resolution of the system is discussed for frequency shift detection of the high-quality peak. For laboratory-based frequency detection systems, such as Agilent’s 53132A frequency counter, a resolution of 10 parts per million using a 1 s gate time is relatively standard. A maximum sensitivity S_{freq} of 6 Hz/(pT/cm) is observed (Fig. 7). Therefore, the frequency detection scheme has a best-case resolution of 1.6 aT/cm at 1 Hz. While we anticipate thermomechanical noise to experimentally limit the technique at much larger gradient

magnetic fields, this constitutes a four orders of magnitude improved resolution (10,000-fold) for the best-case scenario of the presently designed MEMS single-point gradiometer²⁷.

While this work focuses on employing a Casimir-driven parametric amplifier for MEMS sensing, there are other configurations that may be useful to consider. The electrostatic force acts at larger separations (>100 nm), which may be more resilient to pull-in. Electrostatic forces may also be parametrically amplified^{30,31} and are also non-linear (albeit less sensitive than the Casimir force). Furthermore, it has been discussed that sensitivity varies with separation and therefore with gradient magnetic field input. Although complicated for a highly dynamic system, we suggest the investigation of a null-sensing technique that may enable the device to sit at a single sensitivity. Using an additional feedback mechanism may control the center positions of both oscillators (keeping them constant) and may afford control of a constant high sensitivity, such as the 6 Hz/(pT/cm) reported here.

Resonant MEMS devices such as this design are often limited by several types of noise. The characteristic $1/f$ noise from mechanical and electrical sources will largely not affect the resonator coupling near 1 kHz, but the low-frequency changes in separation that are sought to be measured here will likely be affected. We suggest that techniques such as chopper stabilization and lock-in amplification be employed to reduce this effect. Low-frequency magnetic noise, such as from power lines in an urban area or the Earth’s magnetic field, will interfere with sensitive magnetic measurements. As was experimentally analyzed previously²⁷, this interference presents itself as a torque on the magnet equal to the cross product of the magnetic moment and interference field (in-plane or out-of-plane). Standard gradiometer designs^{23,24} reduce this noise from distant sources by subtracting the signals from two closely spaced magnetic sensors. This spacing is typically on the order of 1 cm, and so by design, our system improves this reduction with a spatial element 0.25 mm in length along the sensitive axis. Furthermore, our technique presents a subtractionless measurement, offering a reduction in associated error for gradiometric measurements. Although a central goal of our technique is to develop a sensor for unshielded biomagnetic measurements, shielding may still be employed to further reduce the interference of low-frequency magnetic fields.

Our design is intended for an ambient temperature and pressure environment, so we anticipate thermomechanical noise to be a dominant influence on our measurements. Thermal damping on each of the resonators is mitigated in part by sine-wave feedback pumping. Our simulations did not investigate noise directly, but the design and experimental implementation may be directly compared to the previous work²⁷. Squeeze film

damping has been shown³⁶ to be common on MEMS devices with gaps smaller than 5 μm , such as those designed in this work. Although we intend for this design to be used in ambient environments, vacuum packaging or cryogenic environments would further reduce the effects of damping. Finally, it was theoretically shown³⁷ that another source of damping for a dynamic Casimir oscillator may arise from the nonuniform relative acceleration of the sphere and plate, which encloses the nonlinear properties of vacuum. It may be interesting to combine our sensitive platform design with cryogenic and magnetic shielding environments to investigate this effect experimentally. We are confident that the design strategies presented in this work, in addition to those that reduce the effects of noise, will profoundly enhance the performance of single-point MEMS gradiometers.

Conclusion

We have investigated the quantum-derived coupling of two resonant microstructures to achieve extremely high sensitivity to changes in a gradient magnetic field. The resonators are coupled by a nonlinear Casimir force, which arises from the electromagnetic interaction between closely spaced dielectrics (near 100 nm) in a sphere-plate geometry. A customized parametric amplification technique is developed, where one resonator is synchronized at double the frequency of the other, and the time delay is tuned to find a steady-state solution. The frequency shift of a high-quality, coupled resonance peak is detected to infer a measured gradient magnetic field. A slowly varying field at 1 Hz is imposed, where the best-case resolution is calculated to be 1.6 aT/cm at a sensitivity of 6 Hz/pT/cm. This is a 10,000-fold improvement on the best-case resolution of the previously designed MEMS single-point gradiometer. Many applications, especially the measurement of biomagnetic fields, already rely on complex quantum metrology. The MEMS quantum-enhanced gradiometer presented in this work paves the way toward unshielded, ambient temperature measurements of extremely weak gradient magnetic fields.

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Author contributions

The design was conceived and refined by D.J.B., D.K.C., M.I., J.J., and Z.Y. The simulation was done by J.J. and Z.Y. with assistance from D.J.B. All data were collected, interpreted, and analyzed by J.J. and Z.Y. The paper was written by J. J. with input from Z.Y. and edited by all authors.

Competing interests

The authors declare no competing interests.

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